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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/066,555	01/31/2002	Joerg Bischoff	509982003300	2744
20872 75	90 10/08/2003		EXAM	INER
MORRISON & FOERSTER LLP			SHAH, KAMINI S	
425 MARKET SAN FRANCIS	STREET SCO, CA 94105-2482		ART UNIT	PAPER NUMBER
			2863	<u> </u>

DATE MAILED: 10/08/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

<u>, </u>			*	W		
		Application No.	Applicant(s)			
		10/066,555	BISCHOFF ET AL.			
	Office Action Summary	Examiner	Art Unit			
		Kamini S Shah	2863			
Period f	The MAILING DATE of this communication apports or Reply	pears on the cover sheet	with the correspondenc address			
THE - External after of the control	MORTENED STATUTORY PERIOD FOR REPL MAILING DATE OF THIS COMMUNICATION. ensions of time may be available under the provisions of 37 CFR 1.1 rSIX (6) MONTHS from the mailing date of this communication. e period for reply specified above is less than thirty (30) days, a repl O period for reply is specified above, the maximum statutory period ure to reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing led patent term adjustment. See 37 CFR 1.704(b).	I36(a). In no event, however, may by within the statutory minimum of t will apply and will expire SIX (6) Mea, cause the application to become	a reply be timely filed irty (30) days will be considered timely. DNTHS from the mailing date of this communication. ABANDONED (35 U.S.C. § 133).			
1)🛛	Responsive to communication(s) filed on <u>07</u>	<u>August 2003</u> .				
2a) <u></u> ☐	This action is FINAL . 2b)⊠ Th	nis action is non-final.				
3)	Since this application is in condition for allow closed in accordance with the practice under					
· _	tion of Claims					
4)	Claim(s) <u>1-91</u> is/are pending in the application					
6 \[]	4a) Of the above claim(s) is/are withdrawn from consideration.					
5)∐	- ` `					
·	Claim(s) <u>1-18,38-45,55-64,70-77,85 and 87</u> is/are rejected. Claim(s) <u>19-37,46-54,65-69,78-84,86 and 88-91</u> is/are objected to.					
•=	Claim(s) are subject to restriction and/o					
•	tion Papers	or election requirement.				
·· _	The specification is objected to by the Examine	er.				
•	The drawing(s) filed on is/are: a) acce		the Examiner.			
	Applicant may not request that any objection to the	e drawing(s) be held in abe	yance. See 37 CFR 1.85(a).			
11)	The proposed drawing correction filed on	_ is: a)□ approved b)□	disapproved by the Examiner.			
	If approved, corrected drawings are required in re	ply to this Office action.				
12)	The oath or declaration is objected to by the Ex	caminer.				
Priority	under 35 U.S.C. §§ 119 and 120					
13)	Acknowledgment is made of a claim for foreig	n priority under 35 U.S.C	. § 119(a)-(d) or (f).			
a)	□ All b)□ Some * c)□ None of:					
	1. Certified copies of the priority documents have been received.					
	2. Certified copies of the priority document	ts have been received in	Application No			
* ;	3. Copies of the certified copies of the prio application from the International Bu See the attached detailed Office action for a list	ireau (PCT Rule 17.2(a))	•	•		
14) 🗌 .	Acknowledgment is made of a claim for domest	ic priority under 35 U.S.0	c. § 119(e) (to a provisional application).			
	a) The translation of the foreign language pro Acknowledgment is made of a claim for domest					
Attachmei	nt(s)					
2) 🔲 Noti	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449) Paper No(s) _	5) Notice	v Summary (PTO-413) Paper No(s) f Informal Patent Application (PTO-152)			

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

2. Claims 1-18, 38-45, 55-64, 70-77, 85, and 87 are rejected under 35

U.S.C. 102(b) as being anticipated by Matsumoto (5,559,598).

Regarding to claimed invention, Matsumoto teaches a position detection apparatus for measuring the positions of mark and a wafer as to claimed overlay measurements for semiconductor wafer, the method/apparatus comprising:

Forming periodic grating on the wafer having first set of gratings formed on wafer using first mask such as first diffraction grating pattern 7a formed on a wafer 6; a second set of grating formed on the wafer using a second mask, such as diffraction grating pattern 7b formed on the wafer 6, see col. 5, lines 39-45. Furthermore, Matsumoto teaches the claimed feature such as first and second sets of gratings are intended to be formed on the wafer with an intended asymmetrical alignment, as in figure 3-4, when the position of the two diffraction gratings, serving as misalignment detection marks, on the surface of the wafer 6, the positions of the diffracted light beams change little, accordingly, the amount of relative misalignment between the diffraction gratings 7a and 7b is obtained in equation 13, see col. 6, lines 59-65 and col. 8, lines 26-32.

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Regarding to claimed zero-order diffraction signal, and is measured using an optical metrology system including an ellipsometer, Matsumoto discloses illuminating means for projecting the light of the light source onto the first and second diffraction gratings so that the first diffraction grating produces first and second diffracted light beams of different diffraction orders or the same diffraction order, see col. 3, lines 57-68. Regarding the claimed diffraction signal is measured using an incident signal with a normal incident angle, Matsumoto discloses the reflected light beam L2 passing through the lens 25 and is incident upon the wafer 6 at incident angle α , see col. 11, lines 25-30.

Regarding independent claims 38, 55, 70 and 85, claims recite similar subject matter either in combination with other dependent claims as in claims 1-18 rejected hereinabove.

Regarding claims 39-45, 56-64, 71-79, and 87, claimed subject is similar to rejected claims 12-14, and are rejected for the similar reasoning.

Allowable Subject Matter

3. Claim's 19-37, 46-54, 65-69, 78-84, 86 and 88-91 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. 4,631,416.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kamini S Shah whose telephone number is 703-305-9590. The examiner can normally be reached on IFP.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John Barlow can be reached on 703-308-3126. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

Kamini S Shah Primary Examiner Art Unit 2863

kss